

VIA FAXSIMILE NO. (703) 872-9310

PATENT  
MIC04 P-106

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Examiner : George A. Goudreau  
Group : 1763  
Confirmation No. : 4253  
Applicant : Imad Mahawili, PhD  
Serial No. : 09/488,309  
Filed : January 20, 2000  
For : REACTOR WITH REMOTE PLASMA SYSTEM AND  
METHOD OF PROCESSING A SEMICONDUCTOR  
SUBSTRATE

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DEC 17 2003

**OFFICIAL**

**Commissioner for Patents  
P.O. Box 1450  
Alexandria VA 22313-1450**

Date of this Paper: December 17, 2003.

Dear Sir:

**PETITION AND FEE FOR  
EXTENSION OF TIME (37 C.F.R. 1.136(a))**

1. This is a petition for an extension of time to respond to the Office Action mailed July 17, 2003, for a period of two months.
  2. Applicant is:

a small entity

verified statement attached  
verified statement filed

x other than small equity

- | <u>Extension<br/>(months)</u> | <u>Fee for other<br/>than small entity</u> | <u>Fee for small<br/>entity</u> |
|-------------------------------|--------------------------------------------|---------------------------------|
| one month                     | \$110.00                                   | \$55.00                         |
| X two months                  | \$420.00                                   | \$210.00                        |
| three months                  | \$950.00                                   | \$475.00                        |

**4. An amendment:**

is filed herewith  has been filed

**5. Fee Payment:**

Please charge the amount of \$420 and any additional fees required or credit any excess fee paid to Deposit Account No. 22-0190. A duplicate of this Petition is attached.

VAN DYKE, GARDNER, LINN & BURKHART, LLP

*Catherine S. Collins*  
Catherine S. Collins  
Registration No. 37 599  
2851 Charlevoix Drive, S.E.  
P.O. Box 888695  
Grand Rapids, MI 49588-8695  
(616) 975-5500

CSC:kusc